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DTOS Rec'd PCT/PTO 28 JAN 2005

33082M239

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Shuhei Ogawa, et al.

International Application No.: PCT/JP2003/009941

International Filing Date: August 5, 2003

U.S. Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : Herewith

Examiner: To Be Assigned

For: ETCHING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the documents noted in the International Search Report (ISR). A copy of the ISR is being filed herewith. According to the ISR, documents AA and AF on the enclosed PTO-1449 are in the same patent family.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,  
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Date: January 28, 2005

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FORM PTO-1449  INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 33082M239	SERIAL NO. To Be Assigned
	Applicant Shuhei Ogawa, et al.	
	FILING DATE Herewith	GROUP ART UNIT To Be Assigned

## U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA	6,326,302	12/4/01	Joubert, et al.			
	AB						
	AC						
	AD						

## FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AE	2000-269184	9/29/00	Japan			Abstract	
	AF	2000-269185	9/29/00	Japan			Abstract	
	AG	2001-308175	11/02/01	Japan			Abstract	
	AK	2002-093778	3/29/02	Japan			Abstract	
	AH	02-148039	6/6/90	Japan			Abstract	
	AI							
	AJ							
	AK							

## OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AL	
	AM	
EXAMINER:		DATE CONSIDERED:
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>		